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**METHOD OF FABRICATING POLYSILICON FILM BY EXCIMER LASER
CRYSTALLIZATION PROCESS**

Appl. No.	:	10/604,687	Confirmation No.	1686
Applicant	:	Kun-chih Lin		
Filed	:	August 11, 2003		
TC/A.U.	:	2822		
Examiner	:	GUERRERO, MARIA F		
Docket No.	:	ADTP0067USA		
Customer No.	:	27765		

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

5 Sir:

In response to the Office action of 11/16/2005, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

10 Remarks/Arguments begin on page 7 of this paper.